



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Barnes, et al.

Serial No.: 09/931,324

Confirmation No.: 3945

Filed: August 16, 2001

For: Adjustable Dual Frequency
Voltage Dividing Plasma Reactor

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Group Art Unit: 1765

Examiner: Binh X. Tran

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on <u>July 28</u> , 2003 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
<u>July 28, 2003</u> Date	<u>Airhamm</u> Signature

RESPONSE TO FINAL OFFICE ACTION DATED MAY 29, 2003

In response to the Final Office Action dated May 29, 2003, having a shortened statutory period for response set to expire on August 29, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/4184/AOP, \$978.00 for excess claim fees, and any additional amount for other fees, including extension of time fees, required to make this response timely and acceptable to the Office.

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks/Arguments begin on page 11 of this paper.

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01 FC:1201 168.00 DA
02 FC:1202 810.00 DA